

AP/2800

Attorney's Docket No.: 10417-101001 / F51-136645M/TOM



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Haruo Hyodo et al. Art Unit : 2822
Serial No. : 09/963,267 Examiner : Ida M. Soward
Filed : September 26, 2001
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

*entry
approved*

BOX AF
Commissioner for Patents
Washington, D.C. 20231

AMENDMENT TO OFFICE OFFICE DATED DECEMBER 20, 2002

In response to the action mailed December 20, 2002, please amend the application as follows:

1/11/03
amdt
3 WE
4/1/03
136645
MAR 28 2003
11/2800 MAIL ROOM

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

MARCH 20, 2003
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